Search Notes

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/725,864	NAKAJIMA ET AL.	
Examiner	Art Unit	
Stephen M. Hepperle	3753	

SEARCHED					
Class	Subclass	Date	Examiner		
137	484.8 505.18 505.37	10/05	SIMP		
429	22				
updated	Search	5/06	SA		
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TNI	INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner		
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SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR		
CI 429–consulted Ex Ryan	10/05	Spo		
EAST	10/05	94		
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